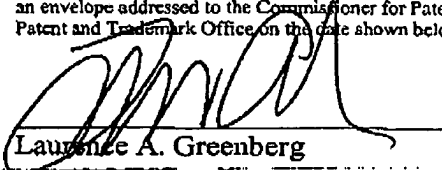


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CERTIFICATION OF MAILING OR TRANSMISSION

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Laurence A. Greenberg

February 4, 2005  
Date

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/635,583 Confirmation No.: 8569  
Inventor : Heiko Hommen, et al.  
Filed : August 6, 2003  
Title : Method for Exosing at Least One or at Least Two Semiconductor  
Wafers  
TC/A.U. : 1756  
Examiner : Christopher G. Young  
Customer No.: 24131

Attention: Douglas Wood, Office of Petitions

Hon. Commissioner for Patents  
Alexandria, VA 22313-1450

LETTER

Sir:

Pursuant to a telephone call from Douglas Wood at the Office of Petitions, counsel herewith submits the required statement/declaration duly executed by the attorney of record, in support of the *Petition under 37 C.F.R. 1.137(a)* submitted on December 20, 2004.

Respectfully submitted,

  
Laurence A. Greenberg (29,308)

Date: February 4, 2005

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